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35.C10499 CONT. I/DIV. I

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
HIDEAKI MITSUTAKE, ET AL.)
Application No.: 09/045,681)
Filed: March 23, 1998)
For: ELECTRON BEAM APPARATUS)
AND IMAGE FORMING)
APPARATUS)

Examiner: A. Patel
Group Art Unit: 2875
April 28, 1999

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The Assistant Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the October 28, 1998 Office Action, the period for response having been extended for three months from January 28, 1999 to April 28, 1999 by the accompanying Petition for Extension of Time, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend Claim 57 as follows:

57. (Amended) An electron beam apparatus comprising:
a vacuum envelope containing a plurality of electron-emitting
devices wired by a plurality of row-directed wires and a plurality of column-directed
wires to form a matrix wiring structure; and
a plate-shaped spacer capable of forming an electrical connection
between a plurality of wires if arranged in electrical contact with the plurality of wires,

C/cont
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